

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Y. KURATA, et al.

Serial No.: 10/049,672

Filed: April 30, 2002

For: POLISHING, MEDIUM FOR CHEMICAL-MECHANICAL  
POLISHING, AND METHOD OF POLISHING SUBSTRATE  
MEMBER

Group: 1765

Examiner: Duy Vu Nguyen Deo  
Conf. No.: 7706

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 12, 2009

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within the third month subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed July 10, 2008. A credit card payment form in the amount of \$1110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (1204.41191X00) and excess fees credited to account.

Respectfully submitted,

/William I. Solomon/

William I. Solomon

Registration No. 28,565

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